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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Complete if Known

Application Number	10/510151
Filing Date	May 30, 2006
First Named Inventor	Kia Silverbrook
Art Unit	2853
Examiner Name	Julian D Huffman
Attorney Docket Number	YU181NPUS

Sheet	1	of	2
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U. S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T ⁶
		Country Code ³ *Number ⁴ *Kind Code ⁵ (if known)				
		JP 03-065348 A	Mar 20 1991	Matsushita Elec Ind Co Ltd		<input checked="" type="checkbox"/>
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NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		ATAKA, MANABU et al, "Fabrication and Operation of Polymide Bimorph Actuators for Ciliary Motion System". Journal of Microelectromechanical Systems, US, IEEE Inc. New York, Vol. 2, no. 4, 1 December 1993, pp 146-150, XP000443412, ISSN: 1057-7157.	✓
		NOWOROLSKI J M ET AL: "Process for in-plane and out-of-plane single-crystal-silicon thermal microactuators" Sensors And Actuators A, Ch. Elsevier Sequoia S.A., Lausanne, Vol 55, no. 1, 15 July 1996 (1996-07-15), Pages 65-69, XP004077979	✓
		YAMAGATA, YUTAKA et al, "A Micro Mobile Mechanism Using Thermal Expansion and its Theoretical Analysis". Proceedings of the workshop on micro electro mechanical systems (MEMS), US, New York, IEEE, Vol. Workshop 7, 25 January 1994, pp 142-147, XP000528408, ISBN: 0-7803-1834-X.	✓

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